



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date April 4, 2003

In re the Application of

Naomasa SHIRAISHI

Group Art Unit: 2851

Application No.: 09/690,591

Examiner: K. Brown

Filed: October 18, 2000

Docket No.: 107629

For: EXPOSURE METHOD AND APPARATUS, AND
METHOD OF FABRICATING A DEVICE

#7
415-03
JPM

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired January 4, 2003, an extension of time for a period of 3 months is hereby requested. Attached hereto is our Check No. 140964 in the amount of \$930.00 in payment for:

_____ Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
_____ Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
XX Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
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